

**Search Notes**

Application/Control No.

10/810,366

Examiner

SANG KIM

Applicant(s)/Patent under  
Reexamination

FIEDLER, LEE

Art Unit

3654

**SEARCHED**

Class	Subclass	Date	Examiner
242	530.1	1/31/2006	SK
242	533.4	1/31/2006	SK
242	535.4	1/31/2006	SK
242	532.2	1/31/2006	SK
242	547	1/31/2006	SK
242	548	1/31/2006	SK
242	532	1/31/2006	SK
242	532.7	1/31/2006	SK

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
John Nguyen: 242/530.1, 533.4, 535.4, 532.2, 547, 548, 532, 532.7	1/30/2006	SK
Kathy Matecki: Text Search	2/3/2006	SK